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Ultrathin junctions based on the LaSrMnO₃/Nb:SrTiO₃ functional oxide interface

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ABSTRACT

High-quality all-oxide thin film metal–semiconductor junctions, fabricated of a half-metallic ferromagnet La_{0.7}Sr_{0.3}MnO₃ and of a niobium doped n-type semiconductor SrTiO₃ (SrTi_{0.8}Nb_{0.2}O₃) by pulsed laser deposition, were studied in terms of their electronic transport properties in a wide temperature range. A fabrication process for ultrathin film metal–semiconductor junctions with micrometre-sized mesas has been established. The current–voltage characteristics of the junctions were found at variance with the conventional thermionic emission theory often applied to explain the transport properties of Schottky contacts. This discrepancy is tentatively ascribed to the very high electric field in the ultrathin SrTi_{0.8}Nb_{0.2}O₃ layer and its effect on carrier depletion and dielectric constant.

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1. Introduction

Metal–semiconductor interfaces are an integral part of our life: most of the modern electronic devices contain metal–semiconductor contacts [1]. In recent years, Schottky contacts formed by functional oxides LaSrMnO₃ (LSMO) and niobium-doped SrTiO₃ (Nb:STO) have attracted increasing interest [2–5]. These two perovskites are well known for their remarkable physical properties, widely used in oxide heterostructures and have a high potential for future spintronic applications [6–11].

Nevertheless, in spite of extensive research, the complex interplay of various parameters at oxide metal–semiconductor interfaces remains an open question. In particular, published studies on LSMO/Nb:STO Schottky contacts are usually carried out on Nb:STO bulk-based samples. Only few studies on such junctions in thin film configuration are known, despite their importance for applications in micro- and nano-electronics. However, in these works relatively thick films were used [12], or the junction structure differs noticeably from the one that we investigated [13,14].

Here we report on fabrication and temperature dependent transport studies of epitaxially grown ultrathin LSMO/Nb:STO metal–semiconductor junctions with micrometre-sized mesas. We show, that for thin film Schottky junctions, transport characteristics near room temperature and at low applied bias can be explained by the thermionic

emission theory. For low temperatures and large electric fields, a deviation from thermionic emission theory is observed. We discuss this result regarding the probable effect of electric field- and temperature-dependent permittivity on transport characteristics in ultrathin metal–semiconductor junctions.

The ability to controlled creation of tailored metal–semiconductor interfaces with desired parameters is crucial for the development of novel spintronic devices.

2. Experimental details

Bilayers consisting of SrTi_{0.8}Nb_{0.2}O₃ on top of La_{0.7}Sr_{0.3}MnO₃ were in situ grown by pulsed laser deposition on TiO₂ single terminated, (100) oriented SrTiO₃ substrates with 0.1° miscut. A KrF excimer laser with 248 nm wavelength and 2 Hz repetition rate was used. The deposition rates were 0.05 and 0.09 monolayer per pulse for LSMO and Nb:STO respectively. We held the substrate temperature constant at 600 °C and the oxygen background pressure at 16 Pa for LSMO and 1.6 Pa for Nb:STO during the deposition. After the deposition the bilayers were in situ annealed in pure oxygen atmosphere under 1 kPa.

In order to analyse surface morphology and crystallographic properties of our samples we performed atomic force microscopy (AFM) measurements, using Veeco Innova model in the contact mode, and X-ray diffraction (XRD) analysis, applying a PANalytical X'Pert Pro diffractometer (Cu-K_α with $\lambda = 1.5406 \text{ \AA}$) in the parallel beam configuration. Layer thicknesses were obtained using X-ray reflectivity technique. We varied the Nb:STO thickness in our samples from 2.4 nm to 18 nm, and LSMO layer thickness from 50 nm to 65 nm.

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Fig. 1. a) Schematic side view of a LSMO/Nb:STO junction; b) top view of a junction with connections.

Junctions (Fig. 1a) with different sized mesa areas (from $25 \mu\text{m}^2$ to $10^4 \mu\text{m}^2$) were fabricated using optical lithography and chemically assisted ion beam etching controlled by a secondary ion mass spectrometer. Two types of junctions were fabricated: type *AP* with aluminium (Al) and palladium (Pd) pads on top of Nb:STO and LSMO respectively, to insure good ohmic contacts [15,16], thus forming an asymmetric metal–semiconductor (LSMO/Nb:STO) junction; type *P* with Pd on both electrodes, Nb:STO and LSMO, to create an additional non-ohmic contact on the semiconductor side, resulting in a symmetric metal–semiconductor–metal (LSMO/Nb:STO/Pd) junction. In both cases sputtering method was used to form the contacting pads. To connect the junctions to the cryostat for transport measurements we used wire bonding.

Transport measurements were performed in the 300 K–77 K temperature range. Samples were mounted on a vacuum insert and then placed in liquid nitrogen. We measured current–voltage characteristics of our junctions with a Keithley 2636 A source meter. Forward bias direction was defined as the positive voltage applied on the LSMO side (Fig. 1).

In the presented study we focus on the 4 nm Nb:STO/50 nm LSMO sample, with Al connection pads on the Nb:STO side.

3. Results

3.1. Structural characterization of thin films

Deposited thin film bilayers demonstrate under the AFM a smooth surface, with root mean square roughness of 0.4 nm. (Fig. 2a). In Fig. 2b X-ray 2-Theta-Omega scans are presented.

Since the intensity of the Nb:STO (002) XRD peak for the samples with ultrathin (2.4–4 nm) Nb:STO layer was not high enough to obtain Nb:STO lattice parameter, we used as reference the sample with 18 nm Nb:STO on top of 50 nm LSMO. With this method Nb:STO lattice parameter of 0.398 nm was measured, which is in good agreement with previously reported results for the same level of Nb doping in STO [17].

We conclude from the results of surface and structural analysis that the obtained thin films are of good crystalline quality.

3.2. Temperature-dependent transport measurements

Nb:STO/LSMO junctions of *AP* type exhibit rectifying behaviour in the whole measured temperature range (300 K–77 K). The rectification ratio was determined as the ratio of current density at 2 V to that at

Fig. 2. a) $2 \times 2 \mu\text{m}^2$ AFM image of Nb:STO surface; b) X-Ray diffraction scans of the samples with 4 nm Nb:STO/50 nm LSMO (top, red) and 18 nm Nb:STO/50 nm LSMO (bottom, blue).

–2 V. The rectification ratio of the sample with 4 nm Nb:STO layer (sample *I*) was approximately 30 at low temperature. We explain this relatively low rectification by the ultrathin film structure of the sample, leading to a potential profile in the Nb:STO film dominated by both interfaces, LSMO/Nb:STO and Nb:STO/Al. In contrast, the rectification ratio of the sample with 18 nm Nb:STO (sample *II*) is more than an order of magnitude higher, indicating a potential profile closer to that of a classical rectifying junction. Another distinction between the two AP samples is a lower current in sample *II*, especially in the reverse direction. At low temperature the reverse current is at least three orders of magnitude smaller than in sample *I* and below nano-ampere range, reaching the limit of our measuring system. We observed a faster decrease of the reverse current with decreasing temperature in sample *II*, compared with sample *I*. This explains the higher rectification ratio in sample *II*, especially at low temperature.

The current–voltage characteristics of AP type samples demonstrate a strong temperature dependence (Fig. 3a). In contrast, the sample of *P* type exhibits symmetric, almost temperature-independent current–voltage characteristics over the whole measured temperature range (Fig. 3b). This temperature independence indicates a tunnelling mechanism for the current injection through the Nb:STO layer with Pd contacts. On the other hand, we analysed the current–voltage characteristics of AP type junctions using the standard Schottky equation for thermionic emission in the case of a reverse biased junction [18]:

$$J = A^* T^2 \exp \left[\frac{-q}{kT} \left(\Phi_B - \sqrt{\frac{qE}{4\pi\epsilon_0\epsilon_{op}}} \right) \right], \quad (1)$$

where J is the current density, A^* is the Richardson constant, here $156 \text{ A cm}^{-2} \text{ K}^{-2}$ [19], T is the temperature, q is the electron charge, k is the Boltzmann constant, Φ_B is the potential barrier height, E is the electric field at the interface, ϵ_0 is the vacuum permittivity and ϵ_{op} is the optical permittivity. Assuming a homogeneous and temperature independent electric field in the Nb:STO layer, taken as $E = V/d$, with d – the layer thickness, we obtain the following expression:

$$J = A^* T^2 \exp \left[\frac{-q}{kT} \left(\Phi_B - \sqrt{\frac{qV}{4\pi d\epsilon_0\epsilon_{op}}} \right) \right]. \quad (2)$$

In Eq. (2) the apparent potential barrier Φ_{App} is defined as:

$$\Phi_{App} = \Phi_B - \sqrt{\frac{qV}{4\pi d\epsilon_0\epsilon_{op}}}. \quad (3)$$

The graphical representation $\ln(J/A^*T^2)$ versus $1/T$ (Fig. 4a) should give the apparent potential barrier as the slope of the straight lines obtained for each voltage. By plotting of the apparent potential barrier versus square root of voltage, we can estimate the Schottky barrier height

Φ_B : we find a value of 0.14 eV, which is much lower than 0.7 eV predicted by the Schottky–Mott rule or values reported by other authors [20–22]. The calculated optical permittivity ϵ_{op} of 33 is non-physically large. An explanation for the failure of this conventional analysis of the temperature dependence is thus probably the influence of the high electric field in the semiconductor. Since the thickness of Nb:STO layer in our junctions is extremely low, this results in a high electric field at the interface even for low applied voltage, and in a fully depleted semiconducting layer.

To verify our conclusion we used an alternative form of the Schottky representation: the voltage dependent representation. Starting from the same equation for thermionic emission in a reverse biased contact (Eq. (1)), we plotted $\ln(J/A^*T^2)$ versus square root of voltage (Fig. 4b).

From Fig. 4b we see, that for room temperature the linear fit and thus the $V^{1/2}$ dependence of the reverse bias current are very good. But for low temperatures, there is a noticeable deviation from the $V^{1/2}$ behaviour for high voltages. Inset in Fig. 4b shows the current–voltage characteristics of sample *II*. There is a clear difference in forward bias, compared with the sample *I* (see Fig. 3a). Sample *II* exhibit in forward bias a transport behaviour as expected for a Schottky junction.

4. Discussion

Conduction mechanism in Schottky junctions at low temperature is often explained by tunnelling, with current–voltage characteristics similar to the ones measured for the *P* type junction (Fig. 3b). But, since in our junctions of AP type the current–voltage characteristics are temperature dependent, tunnelling ansatz does not fit our data correctly.

Some authors, e.g. [23] consider LSMO/Nb:STO junctions as pn-junctions. But the square root of voltage dependent current, as observed in our junctions in a wide temperature range, speaks strongly against the pn-model. Another important indication contradicting the pn-model, is the drastic drop of current in the AP sample *II*.

However, an electric field dependent permittivity in Nb:STO was already reported in [24–26] with the following phenomenological equation:

$$\epsilon_r(E, T) = \frac{b(T)}{\sqrt{a(T) + E^2}}, \quad (4)$$

where $a(T)$ and $b(T)$ are temperature dependent parameters. A deviation of capacitance–voltage (CV) characteristics in Nb:STO Schottky junctions from expected linear behaviour was explained in Ref. [25] using Eq. (4). We measured CV characteristics of our devices and also observed a non-linear behaviour. With $\epsilon(E, T)$ relationship as in Eq. (4) we deduce, that at high electric field the static permittivity in Nb:STO is noticeably lowered. We roughly estimated the depletion width W_D in Nb:STO using the equation expressed by S. M. Sze [18], assuming

Fig. 3. Temperature dependent current–voltage characteristics of measured junctions; the insets show the energy-band diagrams with corresponding metal work functions and electron affinity of Nb:STO; E_F is the Fermi energy, CBM the conduction band minimum, VBM the valence band maximum; a) 100 nm Al/4 nm Nb:STO/50 nm LSMO junction (AP type); b) 100 nm Pd/3 nm Nb:STO/65 nm LSMO junction (*P* type).

Fig. 4. a) $\ln(J/A \cdot T^2)$ versus $1/T$ plot for the AP type sample I (b) Voltage-dependent Schottky representation in reverse bias for sample I at 300 K (red triangles) with corresponding linear fit (black line) and 80 K (blue circles), and for the sample II at 300 K (brown squares); the inset shows current–voltage characteristic of the sample II at 300 K.

the build-in potential $\phi_{bi} = 0.7$ V, carrier density $N_D = 10^{20} \text{ cm}^{-3}$, voltage $V = 0$, temperature $T = 300$ K, and the field dependent permittivity, as calculated in [25], i.e. $\epsilon_r = 40$ and $\epsilon_r = 180$ for the sample with 4 nm Nb:STO and the reference sample respectively. The carrier density was estimated from capacitance–voltage measurements performed at 300 K. The obtained value is lower than expected for this doping level ($\sim 10^{21} \text{ cm}^{-3}$) and an indication for partially inactive dopants. The calculated depletion width W_D was found to be close to 5.5 nm for the junction with 4 nm Nb:STO layer and circa 12 nm for the reference sample with 18 nm Nb:STO. Thus, we assume that the Nb:STO layer is fully depleted in both types of ultrathin film junctions: *P* and *AP*.

Assuming a fully depleted Nb:STO layer, the electric field in the positively charged (ionized Nb donors) layer would depend on this static permittivity, thus becoming both: voltage- and temperature-dependent, at variance with the simple $E = V/d$ picture. This effect is a possible explanation for the observed deviation from thermionic emission model at low temperature and large electric field.

5. Conclusions

Summarized, we have fabricated and analysed ultrathin all-oxide Schottky junctions formed by the metallic oxide LSMO and heavily doped semiconductor Nb:STO. Transport characteristics at high temperature were analysed in the frame of the thermionic emission theory. At low temperature we observed a possible strong dependence of permittivity on electric field. The result of our analysis points toward an importance of further investigations on complex oxide metal–semiconductor interfaces for spintronic applications.

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